

Notice of References Cited			Application/Control No.	Applicant(s)/Patent Under Reexamination	
			10/074,128	BOWER ET AL.	
Examiner			Wesley D Markham	Art Unit	Page 1 of 1

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	V	Cui et al., "Aligned Carbon Nanotubes Via Microwave Plasma Enhanced Chemical Vapor Deposition", Mat. Res. Soc. Symp. Proc. Vol.593, pages 39-44, July 2000
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.